

03560.002791.

Sir:

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| In re Application of: | |) : | Examiner: H.R. Harper | | | |
|--|--|-------------|-----------------------|-----------------|-----------|-----|
| KEISHI DANJO ET AL. | |) | * | | * | |
| Application No.: 09/846,555 | | :) : | Group Art Unit: 2879 | | | |
| Filed: April 30, 2001 | |) | | | | |
| For: | SUBSTRATE FOR FORMING AN ELECTRON SOURCE, ELECTRON SOURCE, AND IMAGE DISPLAY DEVICE | , | January 5, 2004 | | | |
| Mail Stop Non Fee Amendment Commissioner for Patents | | | | TEC | e e og | 5,5 |
| P.O. Box 1 Alexandria | 1450 a, VA 22313-1450 | | | ECHNOLOGY CENTE | JAN 12 21 | (|
| AMENDMENT | | | | | 2004 | |

In response to the Office Action of October 3, 2003, for which a response is due by January 5, 2004, please amend the above identified application as follows.

The claims are listed beginning at page 2. The Remarks begin at page 11.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on January 5, 2004.

(Date of Deposit)

FRANK A. DeLUCIA, JR. (Reg. #42,476)
(Name of Attorney for Applicant)

January 5, 2004
Signature Date of Signature